



Docket No.: HI-024

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inter Application of

Seok Moon KANG

Serial No.: 09/735,547

Confirm. No.: 6563

Filed: December 14, 2000

For: CDMA BASE STATION SYSTEM

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: Group Art Unit: 2685
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: Examiner: Nhan T. LE
:
: Customer No.: 34610

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A/O

REPLY TO RESTRICTION REQUIREMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window
Crystal Plaza Two, Lobby, Room 1B03
Arlington, Virginia 22202

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Technology Center 2600

Sir:

In reply to the Office Action of February 17, 2004 wherein restriction has been required, Applicant hereby elects Group I (claims 1-23), with traverse, for prosecution in the above-identified application.

It is respectfully submitted that the subject matter of each of the designated inventions is sufficiently related that a thorough search for the subject matter of each of the designated inventions would encompass a search for the subject matter of the remaining designated inventions. Thus, it is respectfully submitted that the search and examination of the entire application could be made without serious burden. See MPEP §803 in which it states that "if the search and examination of an entire application can be made without serious burden, the Examiner must examine it on the merits, even though it includes claims to distinct or

independent inventions." It is respectfully submitted that this policy should apply in the present application in order to avoid unnecessary delay and expense to Applicant and duplicative examination by the U.S. Patent and Trademark Office.

If the Examiner believes that any additional changes would place the application in better condition for allowance, the Examiner is invited to contact the undersigned attorney, Daniel Y.J. Kim, at the telephone number listed below.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 16-0607 and please credit any excess fees to such deposit account.

Respectfully submitted,
FLESHNER & KIM, LLP

Daniel Y.J. Kim
Registration No. 36,186

P.O. Box 221200
Chantilly, Virginia 20153-1200
703 766-3701 DYK/dak
Date: March 10, 2004

Please direct all correspondence to Customer Number 34610

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